



1765

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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): T. KAWAGUCHI, et al  
Serial No.: 10/083,252  
Filed: February 27, 2002  
For: PLASMA PROCESSING METHOD AND APPARATUS  
Group: 1765  
Examiner: S. Ahmed

**AMENDMENT**

**RECEIVED**  
OCT 24 2003  
TC 1700

Mail Stop Non-Fee Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

October 21, 2003

Sir:

In response to the Office Action dated September 24, 2003, the following amendments and remarks are respectfully submitted in connection with the above-identified application, as listed below and as set forth on the following pages:

Amendment of the Title of the Invention;  
Amendment of the Abstract;  
Amendments to the Claims; and  
Remarks are included following the amendments.